FEB 16 2015 EST TRIBUTION TO THE PARTY OF TH

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re PATENT APPLICATION of:

Confirmation Number: 4104

Client Reference: FKL-020

**NORIAKI FUKIAGE** 

Application No.: 10/812,354

Group Art Unit: 1762

Filed: March 30, 2004

Examiner:

For: METHOD OF IMPROVING THE WAFER TO WAFER UNIFORMITY AND

DEFECTIVITY OF A DEPOSITED DIELECTRIC FILM

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

## AMENDMENT/RESPONSE TRANSMITTAL

Transmitted herewith is an amendment/response for this application.

## **FEES**

The fee for claims and extension of time (37 C.F.R. 1.16 and 1.17) has been calculated as shown below:

	CLAIMS				<del></del>					
		HIGH	JEST NO	•						
	REMAINING HIGHEST NO.  AFTER PREVIOUSLY PRESENT  AMENDMENT PAID FOR EXTRA RA						TE	ADDIT. FEE		
						х				
TOTAL	34	_	33	=	1	\$	50.00	=	\$	50.00
						х				
INDEP.	2	_	3	=	0	\$	200.00	=	\$	0.00
FIRST PRESENTATION OF MULTIPLE DEP. +										
CLAIM						\$	360.00	=	\$	0.00
TOTAL ADDITIONAL CLAIM FEE									\$	50.00
GRAND TOTAL									\$	50.00

## **FEE PAYMENT**

Authorization is hereby made to charge the amount of \$50.00 to Deposit Account No. 033975. Charge any additional fees required by this paper or credit any overpayment in the manner authorized above. A duplicate of this paper is attached.

Date: February 16, 2005

PILLSBURY WINTHROP LLP

P.O. Box 10500 McLean, VA 22102 703. 905.2110 JEFFREY D. KABCESKI Reg. No. 35914